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(71) Applicant: Applied Materials, Inc.
Santa Clara, California 95054 (US)

(72) Inventors:

- Arackaparambil, John
San Carlos, CA 94010 (US)
- Chi, Tom
San Jose, CA 95127 (US)
- Chow, Billy
Menlo Park, CA 94025 (US)
- D'Souza, Patrick M.
Apex, NC 27502-6657 (US)
- Hawkins, Parris
Pleasanton, CA 94566 (US)
- Huang, Charles
Union City, CA 94587 (US)

- Jensen, Jett
Campbell, CA 95008 (US)
- Krishnamurthy, Badri N.
Mountain View, CA 94043 (US)
- Kulkarni, Pradeep M.
Sunnyvale, CA 94087 (US)
- Kulkarni, Prakash M.
Sunnyvale, CA 94086 (US)
- Lin, Wen Fong
San Jose, CA 95129 (US)
- Mohan, Shantha
Palo Alto, CA 94306 (US)
- Nandy, Bishnu
Union City, CA 94587 (US)
- Yuan, Huey-Shin
Cupertino, CA 95014 (US)

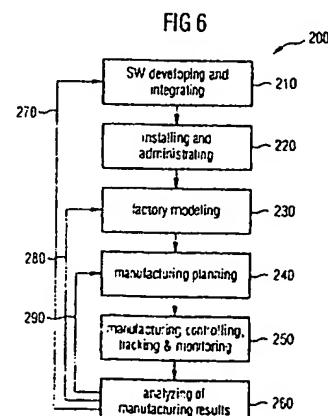
(74) Representative:

Kirschner, Klaus Dieter, Dipl.-Phys.
Schneiders & Behrendt
Rechtsanwälte - Patentanwälte
Sollner Strasse 38
81479 München (DE)

(54) Computer integrated manufacturing techniques

(57) The present invention provides a novel distributed factory system framework including a novel factory automation lifecycle (200) having lifecycle activities for SW developing and integrating (210), installing and administrating (220), factory modeling (230), manufacturing planning (240), manufacturing controlling, monitoring and tracking (250) and analyzing of manufacturing results (260). The factory lifecycle comprises framework components. The distributed factory system framework also includes application components and SW building blocks. The framework components are adapted for managing the application components, while the application components are utilized to provide instructions for managing a process such as a wafer fab. The building blocks are adapted for forming or modifying framework and application components. The distributed factory system framework provides computer implemented

methods for integrating processing systems and facilitates process and equipment changes.





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EUROPEAN SEARCH REPORT

Application Number

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The present search report has been drawn up for all claims					
Place of search	Date of completion of the search	Examiner			
MUNICH	27 September 2001	Helot, H			
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